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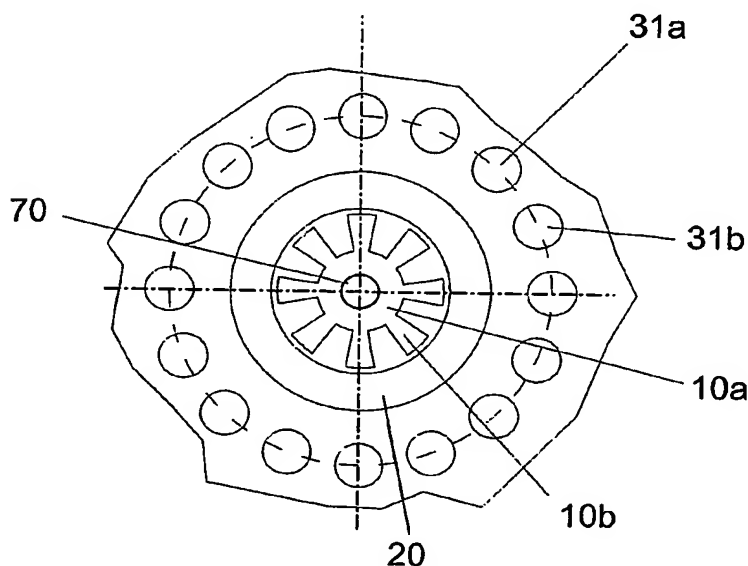
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(54) Title: BURNER FOR CHEMICAL VAPOUR DEPOSITION OF GLASS



(57) Abstract: A burner for a vapour deposition process has a central nozzle (10) for ejecting a glass precursor material, at least a crown of nozzles (31) surrounding said central nozzle (10) for ejecting a flame reactant, and a circular nozzle (20) between said central nozzle (10) and said crown of nozzles (31) for ejecting an innershield gas, wherein the central nozzle (10) has a concave shape in a cross section in the axial plane and, preferably, a symmetry about an axial plane.

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For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.

BURNER FOR CHEMICAL VAPOUR DEPOSITION OF GLASS

This invention relates to a burner for a chemical vapour deposition process, in particular for a chemical vapour deposition process for the manufacturing of a glass preform suitable for drawing an optical fibre.

Two typical processes for producing a glass preform suitable for drawing an optical fibre are the OVD (Outside Vapor Deposition) and the VAD (Vapor-phase Axial Deposition). In these techniques, a burner is used to generate a flame and to eject one or more substances that react in the flame to form silica soot (and being therefore called "silica precursors"), which is deposited onto a rotating mandrel.

Conventional burners for manufacturing optical preforms comprise a plurality of co-axial ducts, terminating in corresponding nozzles wherein the gases are ejected. During the process, the burner is fed with a silica precursor (such as SiCl_4 , optionally together with dopants materials, such as GeCl_4), combusting gases (e.g. oxygen and hydrogen or methane) and, optionally, some inert gas (e.g. nitrogen, argon or helium). Typically, the glass precursor material is fed through the central duct. The combustible gases comprise a combustible gas containing hydrogen and an auxiliary gas, typically oxygen, that aids the combustible gas to generate a flame. In the gas stream so composed, H_2O is produced as a result of the combustion reaction.

When the silica precursor is SiCl_4 , silica synthesis is achieved through two different physical-chemical processes: a main process of diffusive hydrolysis between the precursor and the combustion product (H_2O) by the reaction $\text{SiCl}_4 + 2\text{H}_2\text{O} \rightarrow \text{SiO}_2 + 4\text{HCl}$, and a secondary process of premixed oxidation, active at very high temperatures (usually greater than 1000°C), by the reaction $\text{SiCl}_4 + \text{O}_2 \rightarrow \text{SiO}_2 + 2\text{Cl}_2$. An alternative silica precursor is OMTCS (octamethylcyclotetrasiloxane) and premixed oxidation is in this case the only process involved in silica synthesis.

The Applicant has identified, by experimental tests and numeric simulations, two physical phenomena that may limit the complete

transformation of the precursor and, as a result, the process yield: penetration of H_2O into the SiCl_4 stream (or of O_2 into the OMTCS stream), and heat penetration into the stream of precursor and forming soot. Reduced heat penetration results, in particular, in a reduced particle heating and in a reduced thermophoretic effect.

The presence of these two phenomena is particularly problematic when a high deposition rate is required. In fact, although an easy way of increasing the reactant flow rate without excessively increasing the exit speed thereof would be to increase the reactant nozzle cross-section (and, accordingly, the burner dimensions), the intense flows produced by such a burner would thwart the above described phenomena, leading to low-efficient processes.

Two burners of a conventional type are described in US 3,565,346 and US 5,922,100.

US 3,565,346 describes a burner having a central circular nozzle for the vaporized silicon tetrachloride, an annular sheath opening surrounding the central nozzle for the exit of an oxygen-containing gas, and a plurality of apertures symmetrically disposed around the annular sheath in a cylindrical configuration, for ejecting a combustible gas.

US 5,922,100 discloses a burner having a central circular nozzle for OMCTS+ O_2 , an annular opening surrounding the central nozzle for ejecting N_2 , two rings of orifices around the annular opening for ejecting O_2 , and an outer ring of orifices for ejecting $\text{CH}_4 + \text{O}_2$.

It has been observed that these two type of burner can provide good performances only with relatively low reactant flow rates.

JP04-228440 proposes a high-yield multi-flame burner, having the precursor ejecting port of elliptic or rectangular shape, able to improve the deposition yield up to 65% with respect to burners having the precursor ejecting port of circular shape.

The Applicant has tackled the problem of providing a burner able to improve the above described phenomena of penetration of H_2O into the SiCl_4

stream (or of O₂ into the OMTCS stream) and heat penetration into the stream of precursor and forming soot, so as to increase the process yield.

The Applicant has found that, by providing a precursor exit port of "concave" cross section, the contact surface between the precursor and the reactant allowing its transformation into glass soot is increased; as a result, both said phenomena are improved and the process yield is increased.

For the purposes of the present invention, with "concave" shape it is intended any planar geometrical shape that is not "convex", wherein a planar geometrical shape is "convex" if it contains all the line segments connecting any pair of its points. Thus, for example, a star is a concave shape, while a circle and a rectangle are convex shapes.

The reactant is preferably H₂O when the precursor is SiCl₄, and O₂ when the precursor is OMCTS.

This invention therefore relates to a burner for a vapour deposition process having a central nozzle for ejecting a glass precursor material, wherein the central nozzle has a concave shape.

Preferably, the central nozzle has symmetry about an axial plane.

The burner preferably comprises at least a crown of nozzles surrounding said central nozzle, for ejecting a flame reactant. The burner also preferably comprises a circular nozzle between said central nozzle and said crown of nozzles for ejecting an innershield gas.

The central nozzle may advantageously have first angular sectors of minimum radial dimensions and second angular sectors of maximum radial dimensions.

The at least a crown of nozzles may comprise a first set of nozzles in the same angular positions of said second angular sectors and a second set of nozzles in the same angular positions of said first angular sectors.

Moreover, the burner preferably comprises a first set of orifices exiting in said first set of nozzles and a second set of orifices exiting in said second set of nozzles, the orifices of the first set being inclined of a first angle with respect to a central axis of said burner and the orifices of the second set being

inclined of a second angle with respect to said central axis, said second angle being greater than said first angle.

Preferably, the burner has a central duct exiting in said central nozzle for the passage of said glass precursor material, and comprises a central member positioned inside the central duct for forcing the glass precursor material toward the external boundary of said central nozzle.

The central member may have at least an enlarged portion that substantially fits with external walls of said central duct.

In a second aspect thereof, the present invention relates to a chemical vapor deposition process, comprising ejecting a stream of glass precursor material having a concave cross section.

Advantageously, the process may further comprise producing a flame around said stream of glass precursor material and ejecting an innershield gas between said stream of glass precursor material and said flame.

Preferably, the stream of glass precursor material has a central axis, said cross-section has first angular zones of maximum radial extension alternated to second angular zones of minimum radial extension, and the step of producing a flame comprises ejecting combustible gases along a first direction with respect to said axis at first angular positions corresponding to said first angular zones and along a second direction with respect to said axis at second angular positions corresponding to said second angular zones, said second angle being greater than said first angle.

Advantageously, the stream of glass precursor material may have its maximum velocity in an annular region around a central axis.

Further details may be found in the following description, which refers to the appended figures listed here:

- **Figure 1** shows the face of a burner according to the present invention;
- **Figure 2** is an enlarged view of the central part of the face of the burner of Figure 1;
- **Figures 3** is a longitudinal cross-section of the burner of the present invention according to line III-III of Figure 1;

- **Figure 4** is an exploded view of the burner of the present invention, cross-sectioned as in Figure 3; and
- **Figures 5a and 5b** show the precursor stream speed profile, in the absence and in the presence of a central pin acting as a flow control member, respectively.

Figure 1 illustrates the face of a burner 1 according to the present invention, particularly suitable for an OVD process. Burner 1 is apt to eject a stream of glass precursor material (briefly referred to as "precursor" in the following), and to generate a flame for uniformly heating said stream, thus causing the precursor to react. As a result, a stream of fine soot glass particles is formed. The soot particles can be deposited onto a rotating rod to form a glass preform, as well known in the art.

Burner 1 has, on its front face, a central nozzle 10, an annular nozzle 20 surrounding the central nozzle 10, and four concentric crowns of nozzles 31, 32, 41, 42 surrounding the circular nozzle 20. A central axis of the burner 1 is indicated with 5.

Burner 1 may for example eject the following gases:

- Central nozzle 10: $\text{SiCl}_4 + \text{O}_2$ (precursor);
- Circular nozzle 20: O_2 (innershield);
- Inner couple of nozzle crowns 31, 32: $\text{CH}_4 + \text{O}_2$ (flame);
- Outer couple of nozzle crowns 41, 42: O_2 (outershield).

According to the present invention, the central nozzle 10 has a "concave" shape (as previously defined), for example as the one illustrated in **Figure 1**.

With reference to **Figure 2**, the central nozzle 10 preferably has a circular central region 10a and a plurality of radial regions 10b extending from the central region 10a. The radial regions 10b are preferably evenly-spaced and may be in even or odd number (eight in the present case). The central nozzle 10 is preferably symmetric with respect to an axial plane, i.e. to a plane containing axis 5 (such as plane III-III in **Figure 1**), such as in a five-points

star shape, and possibly symmetric with respect to axis 5, such as in a six-points star shape.

In the particular embodiment here illustrated, each radial region 10b is delimited by two lateral walls converging towards axis 5 (in particular, laying on respective radial planes) and by an end wall laying on a same circumference as the end walls of the other radial regions, close to the internal boundary of annular nozzle 20.

The particular shape of **Figure 2** allows increasing the external perimeter of the precursor stream of more than 160% with respect to a nozzle having a same cross-sectional area but circular shape. As a result, the area of the precursor stream exposed to the flame is increased and the Reynolds number (defined in the following) and the stream turbulence are decreased.

The radial regions may have different shapes from that illustrated in **Figure 2**, for example may be triangular, such as in a star-like shape.

Burner 1 may also advantageously comprise a central pin 70, whose scope is to regulate the gas distribution in the central nozzle 10, as later described.

With reference to **Figures 3 and 4**, burner 1 preferably comprises a back block 2, a face block 3, and a manifold plate (or intermediate block) 4 interposed between back block 2 and face block 3. These three pieces are preferably made of metal (for example Aluminum) and are releasably coupled to each other, for example by bolts (not shown). Back block 2 is a gas-receiving block connected to a reactants feed system (not shown) for receiving the required gases. Face block 3 defines a gas-ejecting block and has the plurality of exit nozzles previously described.

Preferably, blocks 2, 3 and 4 have a substantially circular cross-section and are substantially coaxial to axis 5. Moreover, blocks 2, 3 and 4 are preferably made of metal, more preferably of aluminium, which can be readily machined; however, other metals suitable to be machined, like stainless steel (e.g., 303 stainless steel), can alternatively be used.

For each block, back and front portions will be identified coherently with the above definition of back block and face block.

Burner 1 defines internally a plurality of gas passages extending from the back block 2 to the nozzles of the face block 3. In particular, burner 1 has
5 four passages 100-400 suitable to convey respective flows of gas. Inside the back block 2 and the manifold plate 4, the first passage 100 is a central rectilinear and cylindrical duct coaxial to axis 5, while inside the face block 3 it is defined by a duct 101 having a cross-section shaped as nozzle 10. Duct 101 is delimited by the internal surface of a central wall 102, whose external
10 surface internally delimits passage 201. The internal surface of wall 102 is grooved so as to show said particular cross-section.

In **Figures 3 and 4**, only the first part of passages 100 and 200 is illustrated, the first part of passages 300 and 400 being in angular positions not crossed by plane III-III of **Figure 1**, but being similar to that of
15 passage 200.

The entrance hole of passages 100-400 is enlarged and threatened to allow coupling of the pipes fittings of the reactants feed system to the back block 2.

Back block 2 is preferably an integrally-formed body of substantially
20 cylindrical shape, having at its base a radial flange 500 for coupling onto a burner mounting block (not shown). For this purpose, radial flange 500 has unthreaded holes 510 for passage of coupling bolts (not shown).

Manifold plate 4 is preferably a disk-like body with the same external diameter of back block 2, having the function of stabilizing the gas pressure and providing uniform gas flows at face block 102. To this aim, passages 100-
25 400 have a minimum, predetermined, dimension inside manifold plate 4, so as to regulate the gas pressure flowing therein. Inside manifold 4, the passages 200-400 are defined by respective crown of orifices, coaxial to axis 5.

Both back block 2 and manifold plate 4 may have, on the respective
30 front surfaces, annular grooves 6 suitable to house respective O-rings, used to

prevent gas leakage among the different passages of burner 1 or towards the external of burner 1.

Preferably, face block 3 has a frusto-conical shape and comprises, at its base, a circular flange 710 having substantially the same external diameter of manifold plate 4 and back block 2.

Burner 1 is provided with holes 7, passing through circular flange 710 of face block, the external part of manifold plate 4 and the front and external portion of back block 2 (wherein they are threatened), to allow coupling of the three pieces by bolts.

In their first part inside face block 3, passages 200, 300 and 400 are annular ducts converging towards axis 5. Then, while passage 200 continues as a circular duct 201 around central passage 100 and terminates in the circular nozzle 20, passages 300 and 400 split each in two crowns of orifices 301, 302 and 401, 402, which terminate in the first couple of nozzle crowns 31, 32 and in the second couple of nozzle crowns 41, 42, respectively.

Preferably, the orifices of the inner crown, i.e. those indicated with 301 and terminating in the nozzles 31, are in a number that is twice the number of the radial regions 10b of the central nozzle 10. Moreover, orifices 301 are so angularly arranged that, as shown in **Figure 2**, half of nozzles 31, indicated with 31a, are aligned with the radial regions 10b and the other half of nozzles 31, indicated with 31b, are interposed between two radial regions 10b.

Advantageously, the slope of orifices 301 depends on the position of the corresponding nozzles with respect to the radial regions 10b. In particular, those orifices 301 terminating in a nozzle 31b, have a slope with respect to the central axis 5 greater than the orifices 301 terminating in a nozzle 31a so as to have a higher penetration power of the flame gas (such as $\text{CH}_4 + \text{O}_2$) into the precursor gas stream. The angles formed by the orifices 301 with axis 5 will be selected according to the shape of the central nozzle 10. Therefore, a first set of orifices 301, terminating in nozzles 31a, will extend along directions forming a first angle with axis 5 and a second set of orifices 301, terminating in nozzles 31b, will extend along directions forming a second angle with axis 5.

The first angle is preferably comprised between 13° and 19° and the second angle is preferably comprised between 17° and 23°.

As shown in **Figure 4**, the central pin 70 is a straight rod-like member with two enlarged portions 70a, 70b, having substantially the same diameter of the central region 10a of the central nozzle 10. The enlarged portions 70a, 70b substantially fit with the external walls of the central region 10a and their function is that of maintain the pin 70 in a centered position. The enlarged portions also contribute in forcing the precursor to flow into the radial regions 10b.

Pin 70 is also provided, at its back end, of a plurality of radial extensions 70c, shaped so as to allow passage of the gas in the interstices thereof. For example, the back end of pin 70 may comprise three extensions forming a triangle with concave sides. The back end of pin 70 is positioned, when the burner is assembled, against a edge 410 on the manifold plate 4.

The central pin 70 has the scope of forcing the precursor to correctly distribute on the external portion of the central nozzle 10, thus causing a decrease of turbulence and of the thickness of precursor stream to be penetrated by H₂O, O₂ or other reactant. **Figures 5a** and **5b** show, respectively, the precursor stream velocity profile at the exit of the burner in the absence and in the presence of pin 70. It can be appreciated that in the presence of the pin 70 the stream is annular and the velocity is higher.

The concave shape of the central nozzle 10 provides, with respect to the traditional convex shape, an increase of the precursor stream surface exposed to flame gases. This results in a series of effects that improve the deposition rate.

A first effect is an increase of the amount of precursor transformed into glass soot particles, through a better diffusion inside the precursor stream of the reactant responsible of its synthesis (H₂O, O₂, etc).

A second effect is the increase of the penetration inside the precursor stream of the heat generated by the flame. The temperature increase in the precursor reaction zone provides several benefits. Firstly, the kinetic of the

silica synthesis reaction is more rapid, since the reaction kinetic constants increase with a temperature increase. Moreover, a higher temperature of the soot particles is achieved, that results in a higher coalescence due to improved particle fluidity, and in an improved thermophoretic effect due to a higher thermal gradient between the particle stream and the preform. A higher deposition rate is thus achieved.

A third effect is a lower consumption of both flame gases and glass precursor, due to the higher reaction efficiency.

The particular shape of the central nozzle 10 provides a further advantage: a reduction of the stream turbulence. If the stream turbulence is too high, the gas layer adhering to the preform surface and flowing thereon with laminar motion, known as "boundary layer", would tend to detach soon from the preform resulting in a reduction of the contact surface between the soot particles stream and the preform itself. This, of course, causes a reduction of the process efficiency, and a control of the stream turbulence is therefore very important.

The turbulence of the precursor stream is related to the Reynolds Number, defined as:

$$Re = \frac{\rho \cdot v \cdot D_H}{\mu}$$

where ρ is the fluid density, v the fluid speed, D_H the hydraulic diameter defined as $4 \cdot (\text{stream section area} / \text{stream section perimeter})$, and μ the fluid viscosity.

The concave shape of the central nozzle 10 provides low values of the area/perimeter ratio and, therefore, low values of the Reynolds Number. It can be verified that burner 1 has a Reynolds Number that is about 66% lower than that of a similar burner having a circular central nozzle.

A low value of the Reynolds Number results in high deposition efficiency, since the stream has a low turbulence and the boundary layer of the flame around the preform has a wide extension.

It will be apparent to those skilled in the art that various modifications and variations can be made to the disclosed embodiment of the present invention without departing from the scope or spirit of the invention.

For example, it can be appreciated that the geometry of second, third and fourth passages 200, 300 and 400 is not basic, and that burner 1 may be made with different geometries and number of passages around the central passage 100.

Example

The Applicant has compared the performances of a burner according to the present invention, in particular a burner as in **Figures 1-4**, with those of a similar burner having a circular central nozzle.

Tables I and II report the characteristics of the two burners, indicated as INV. BURNER (burner of the invention) and COMP. BURNER (comparative burner). The following symbols are used:

- \varnothing_i = inner diameter;
- \varnothing_o = outer diameter;
- $\varnothing_{\text{orif}}$ = diameter of orifices;
- N_{IC} = number of orifices in inner crown;
- N_{OC} = number of orifices in outer crown;
- α : slope of orifices with respect to axis 5; α_{IN} : slope of orifices of inner crown; α_{OUT} : slope of orifices of outer crown;
- A_{10} : cross-section of nozzle 10; A_{70} : cross-section of pin 70.

Table I – COMP. BURNER

Precursor (nozzle 10)	$A_{10}=7.5$ mm^2				
Innershield (nozzle 20)	$\varnothing_i=3.7$ mm	$\varnothing_o=6.5$ mm	$A=22.4$ mm^2	$\alpha=13^\circ$	
Flame (nozzles 31, 32)	$\varnothing_{\text{orif}}=1.2$ mm	$N_{\text{IC}}=20$	$N_{\text{OC}}=27$	$A=53.2$ mm^2	$\alpha=13^\circ$
Outershield (nozzles 41, 42)	$\varnothing_{\text{orif}}=1.2$ mm	$N_{\text{IC}}=40$	$N_{\text{OC}}=40$	$A=90.5$ mm^2	$\alpha=13^\circ$

Table II – INV. BURNER

Precursor (nozzle 10)	$A_{10}=8.1$ mm^2	$A_{70}=0.785$ mm^2			
Innershield (nozzle 20)	$\varnothing_i=4.5$ mm	$\varnothing_o=6.5$ mm	$A=17.3$ mm^2	$\alpha=16^\circ$	
Flame (nozzles 31, 42)	$\varnothing_{\text{orif}}=1.2$ mm	$N_{\text{IC}}=16$	$N_{\text{OC}}=27$	$A=48.6$ mm^2	$\alpha_{\text{IN}}=16^\circ - 20^\circ$ $\alpha_{\text{OUT}}=13^\circ$
Outershield (nozzles 41, 42)	$\varnothing_{\text{orif}}=1.2$ mm	$N_{\text{IC}}=40$	$N_{\text{OC}}=40$	$A=90.5$ mm^2	$\alpha=13^\circ$

The gas flow rates fed to the burners are reported in Table III

5

Table III

	Precursor		Innershield	Flame		Outershield
	SiCl_4 (g/min)	O_2 (slpm)	O_2 (slpm)	CH_4 (slpm)	O_2 (slpm)	O_2 (slpm)
COMP	45	6.5	2.0	28.0	28.0	10.0
INV	45	6.5	2.2	28.0	28.0	10.0

Table IV reports the results of the experiment.

10

Table IV

	Deposition rate (g/min)	Efficiency (%)	Density (g/cc)
COMP	7.6	48	0.52
INV	8.1	51	0.55

The deposition rate and the efficiency have been calculated according to the following relations:

15

$$Dep_rate = \frac{soot_weight}{process_time}$$

$$Eff \% = \frac{soot_weight}{process_time \cdot Q_{prec} \cdot v \cdot \frac{PM_{ox}}{PM_{prec}}} \cdot 100$$

where:

Q_{prec} = precursor ($SiCl_4$, OMTCS, etc.) flow rate (g/min);

PM_{prec} = molecular weight of the precursor;

5 PM_{ox} = molecular weight of the produced oxide (SiO_2 , GeO_2 , etc.);

v = oxide and precursor stoichiometric coefficients ratio.

The higher density of the deposited soot results from a higher temperature of the SiO_2 particles deposited on the preform. It can be appreciated that both the deposition rate and the process efficiency are
10 improved by the use of the burner of the present invention.

Claims

1. A burner (1) for a vapour deposition process, having a central nozzle (10)
for ejecting a glass precursor material, characterized in that said central
5 nozzle (10) has a concave shape.
2. A burner according to claim 1, wherein said central nozzle (10) has a
symmetry about an axial plane.
- 10 3. A burner according to claim 1, further comprising at least a crown of
nozzles (31, 32) surrounding said central nozzle (10) for ejecting a flame
reactant.
4. A burner according to claim 1, further comprising a circular nozzle (20)
15 between said central nozzle (10) and said crown of nozzles (31, 32) for
ejecting an innershield gas.
5. A burner according to claim 4, wherein said central nozzle (10) has first
angular sectors (10a) of minimum radial dimensions and second angular
20 sectors (10b) of maximum radial dimensions.
6. A burner according to claim 5, wherein said at least a crown of nozzles (31)
comprises a first set of nozzles (31a) in the same angular positions of said
second angular sectors (10b) and a second set of nozzles (31b) in the
25 same angular positions of said first angular sectors (10a).
7. A burner according to claim 6, further comprising a first set of orifices
exiting in said first set of nozzles (31a) and a second set of orifices exiting
in said second set of nozzles (31b), the orifices of the first set being inclined
30 of a first angle with respect to a central axis (5) of said burner and the

orifices of the second set being inclined of a second angle with respect to said central axis, said second angle being greater than said first angle.

5 8. A burner according to claim 1, having a central duct (101) exiting in said central nozzle (10) for the passage of said glass precursor material, and comprising a central member (70) positioned inside the central duct (101) for forcing the glass precursor material toward the external boundary of said central nozzle (10).

10 9. A burner according to claim 8, wherein the central member (70) has at least an enlarged portion that substantially fits with external walls (102) of said central duct (101).

15 10. A chemical vapor deposition process, comprising ejecting a stream of glass precursor material having a concave cross section.

20 11. A process according to claim 10, further comprising producing a flame around said stream of glass precursor material and ejecting an innershield gas between said stream of glass precursor material and said flame.

25 12. A process according to claim 10, wherein said stream of glass precursor material has a central axis, wherein said cross-section has first angular zones of maximum radial extension alternated to second angular zones of minimum radial extension, and wherein producing a flame comprises
30 ejecting combustible gases along a first direction with respect to said axis at first angular positions corresponding to said first angular zones and along a second direction with respect to said axis at second angular positions corresponding to said second angular zones, said second angle being greater than said first angle.

13. A process according to claim 10, wherein said stream of glass precursor material is ejected with a velocity that is maximum in a region around a central axis of said stream.

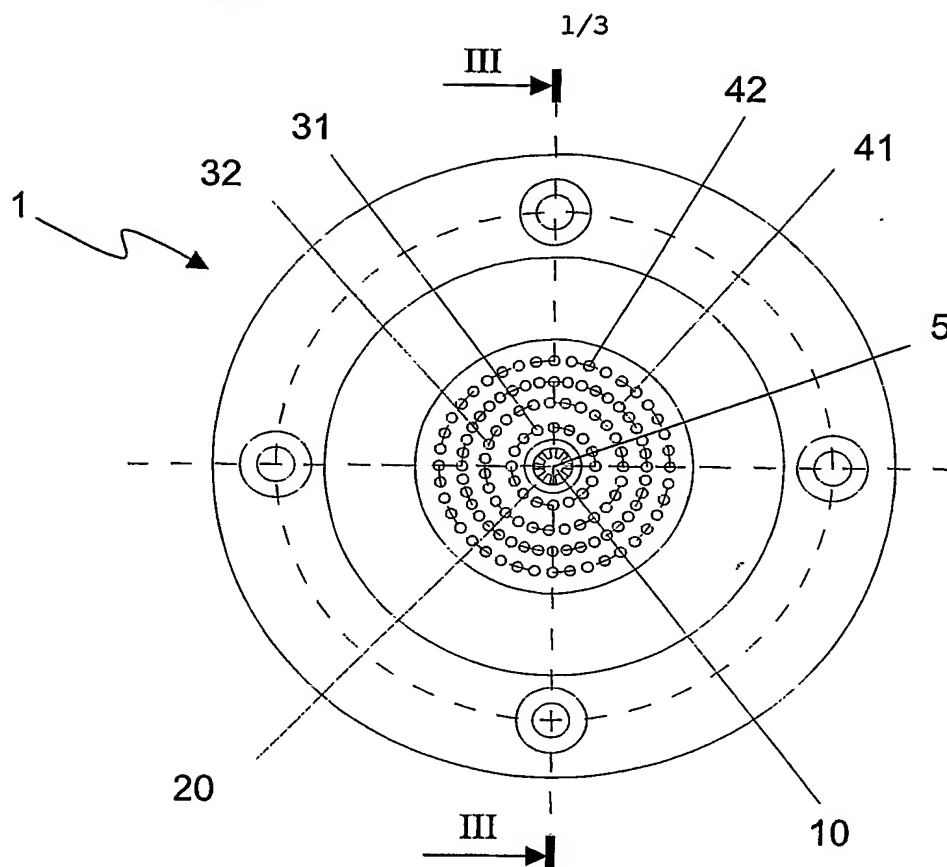


Fig. 1

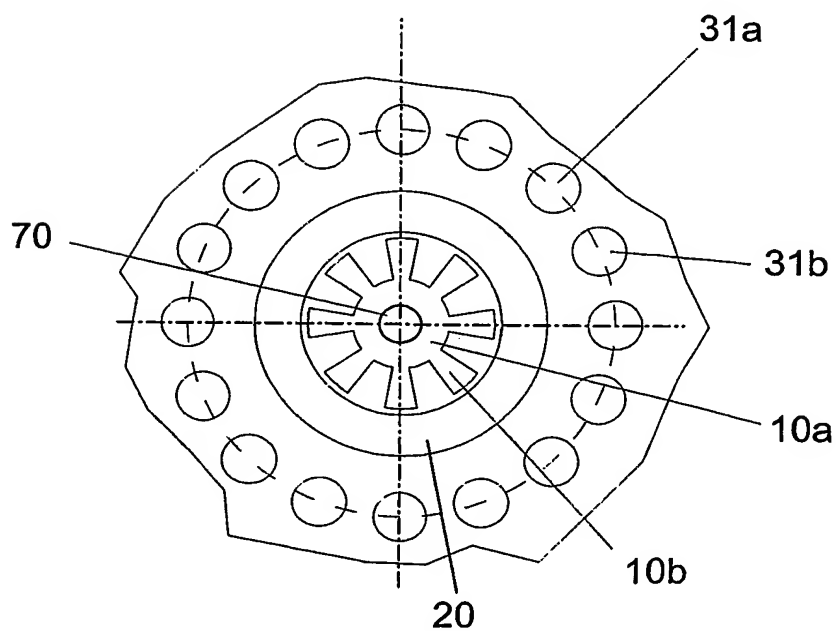


Fig. 2

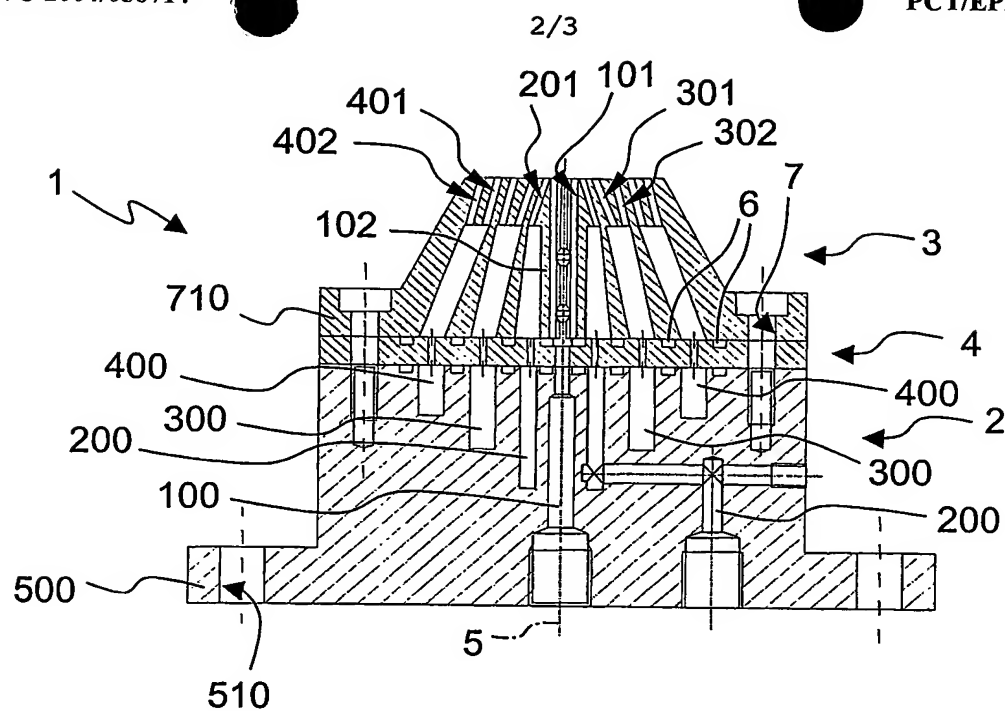


Fig. 3

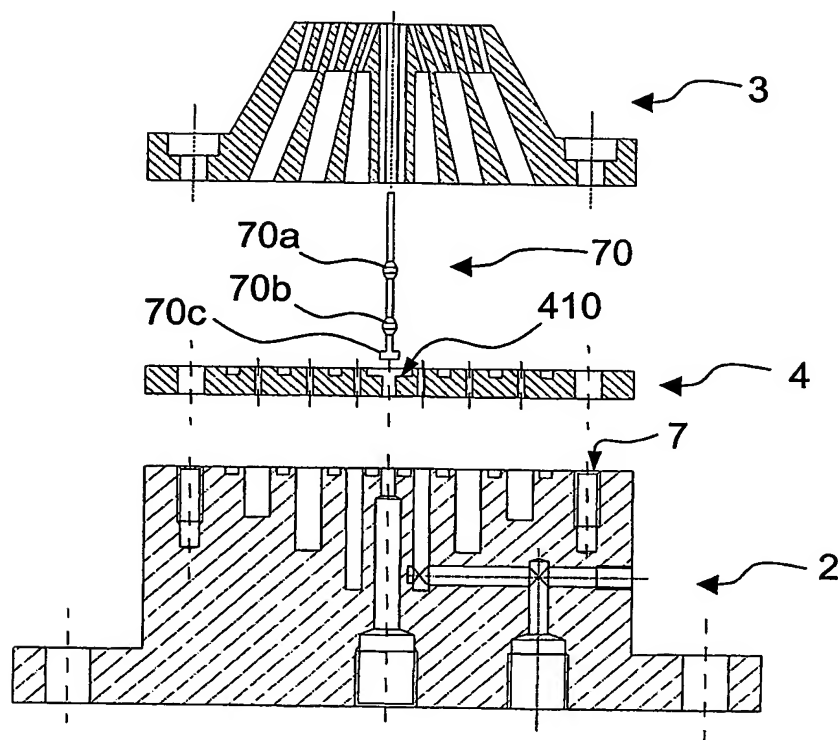


Fig. 4

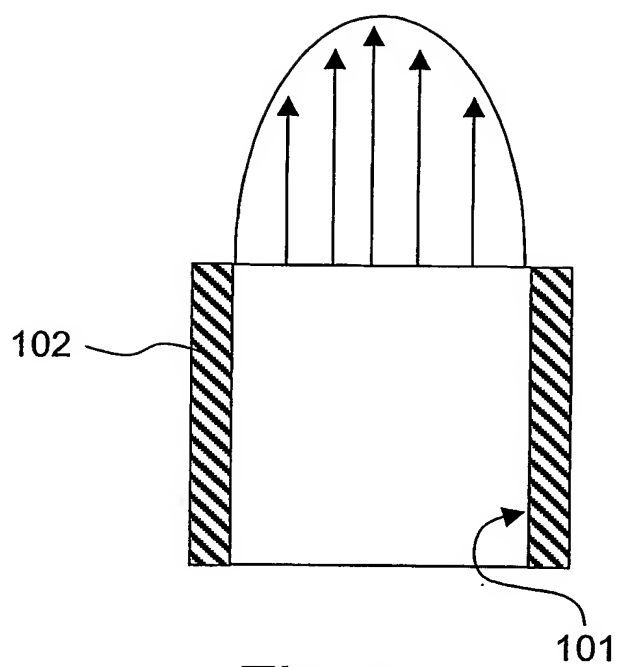


Fig. 5a

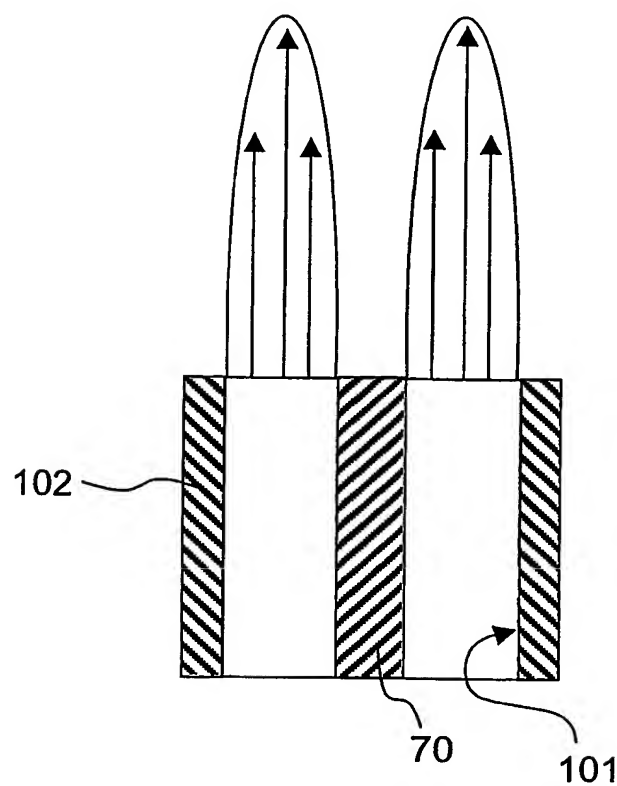


Fig. 5b

INTERNATIONAL SEARCH REPORT

International Application No

PCT/EP 02/14614

A. CLASSIFICATION OF SUBJECT MATTER

IPC 7 C03B19/14 C03B37/014 C23C16/00 C23C16/453

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

IPC 7 C03B C23C

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the International search (name of data base and, where practical, search terms used)

EPO-Internal, PAJ

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category °	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	EP 0 978 487 A (CORNING INC) 9 February 2000 (2000-02-09) page 5, column 25 -page 6, column 43; figures 4-14	1-12
A	---	13
X	PATENT ABSTRACTS OF JAPAN vol. 1998, no. 08, 30 June 1998 (1998-06-30) & JP 10 081534 A (FURUKAWA ELECTRIC CO LTD:THE), 31 March 1998 (1998-03-31) abstract --- -/--	1-13

☒ Further documents are listed in the continuation of box C.

☒ Patent family members are listed in annex.

° Special categories of cited documents :

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Date of the actual completion of the international search

15 July 2003

Date of mailing of the international search report

20. 08. 2003

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INTERNATIONAL SEARCH REPORT

International Application No

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C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT

Category °	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	PATENT ABSTRACTS OF JAPAN vol. 016, no. 575 (C-1011), 15 December 1992 (1992-12-15) & JP 04 228440 A (SUMITOMO ELECTRIC IND LTD), 18 August 1992 (1992-08-18) abstract ---	1-13
A	WO 00 17115 A (BALL LAURA J ;LINDNER RAYMOND E (US); CORNING INC (US); POWERS DAL) 30 March 2000 (2000-03-30) figures 1-5 ---	1-13
A	US 2002/189298 A1 (KUWABARA MASAHIDE ET AL) 19 December 2002 (2002-12-19) page 2, column 1, line 1 -page 3, column 1, line 60; figures 3-9 ---	1-13
A	PATENT ABSTRACTS OF JAPAN vol. 016, no. 455 (C-0987), 22 September 1992 (1992-09-22) & JP 04 160026 A (FUJIKURA LTD), 3 June 1992 (1992-06-03) abstract -----	1-13

INTERNATIONAL SEARCH REPORT

Information on patent family members

International Application No

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